



SN 09/945,535

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al. Examiner: David S. Blum
Serial No.: 09/945,535 Group Art Unit: 2813
Filed: August 30, 2001 Docket: 1303.026US1
Title: HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZRO2

COMMUNICATION CONCERNING RELATED APPLICATION(S)

Mail Stop RCE
Commissioner for Patents
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Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date/Issue Date</u>	<u>Attorney Docket</u>	<u>Title</u>
11/178914	July 11, 2005	1303.061US3	NANOLAMINATES OF HAFNIUM OXIDE AND ZIRCONIUM OXIDE
11/189075	July 25, 2005	1303.148US1	MAGNESIUM TITANIUM OXIDE FILMS
11/215412	August 29, 2005	1303.121US2	RUTHENIUM GATE FOR A LANTHANIDE OXIDE DIELECTRIC LAYER
11/213013	August 26, 2005	1303.090US2	ATOMIC LAYER DEPOSITED DIELECTRIC LAYERS
11/212306	August 26, 2005	1303.097US2	ATOMIC LAYER DEPOSITED ZIRCONIUM TITANIUM OXIDE FILMS
11/204745	August 16, 2005	1303.044US3	EVAPORATION OF Y-Si-O FILMS FOR MEDIUM-k DIELECTRICS
11/214693	August 29, 2005	1303.082US3	ATOMIC LAYER DEPOSITED Zr-Sn-Ti-O FILMS USING TiI4

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

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Respectfully submitted,

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24 Oct '05

By

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 24 day of October, 2005.

Name

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Signature

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